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** CONTINUING DATA **********************************								
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YES IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/01/2003								
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ADDRESS LEE & STERBA, P.C. SUITE 2000 1101 WILSON BOULEVARD ARLINGTON , VA 22209								
A METHOD OF MANUFACTURING THE SEMICONDUCTOR DEVICE INTENDED TO PREVENT TITLE A LEAKAGE CURRENT FROM OCCURING DUE TO A GATE INDUCED DRAIN LEAKAGE EFFECT Semiconductor device and methods of manufacturing the same								
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